

PATENT

Docket No. JCLA16514

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : HIROSHI SAWADA et al.
Application No. : 10/529,376
Filed : 9/20/2005
For : METHOD OF FORMING A PERIODIC STRUCTURE AND
SURFACE TREATMENT
Group Art Unit : 3742

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

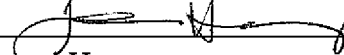
Dear Sir:

Enclosed are the European Search Report and a PTO Form 1449 listing (9) references that are also attached. Each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement. Therefore, no fee is due.

However, the Commissioner is authorized to charge any necessary fee in connection with the filing of this paper to Account No. 50-0710 (Order No. JCLA16514).

Respectfully submitted,
J.C. Patents

Dated: 9-5-2008

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